

Beam Masking and its Smearing due to ISR-Induced Energy Diffusion

Nikolai Yampolsky and Bruce Carlsten

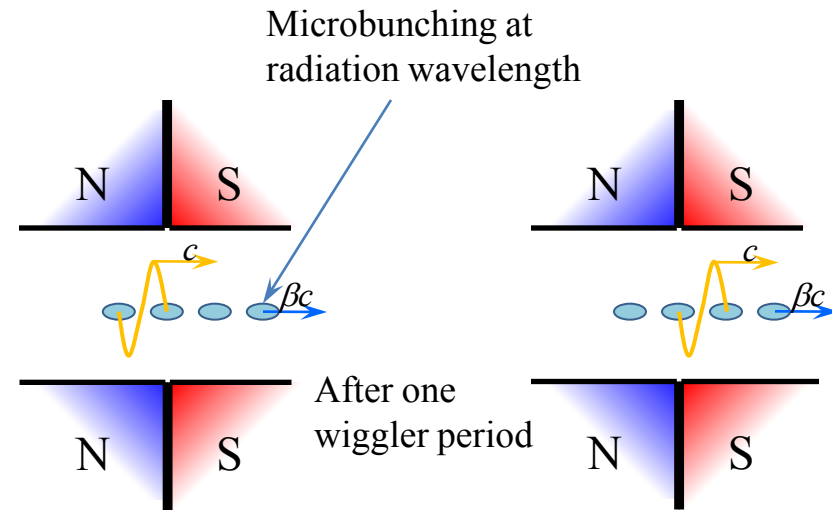
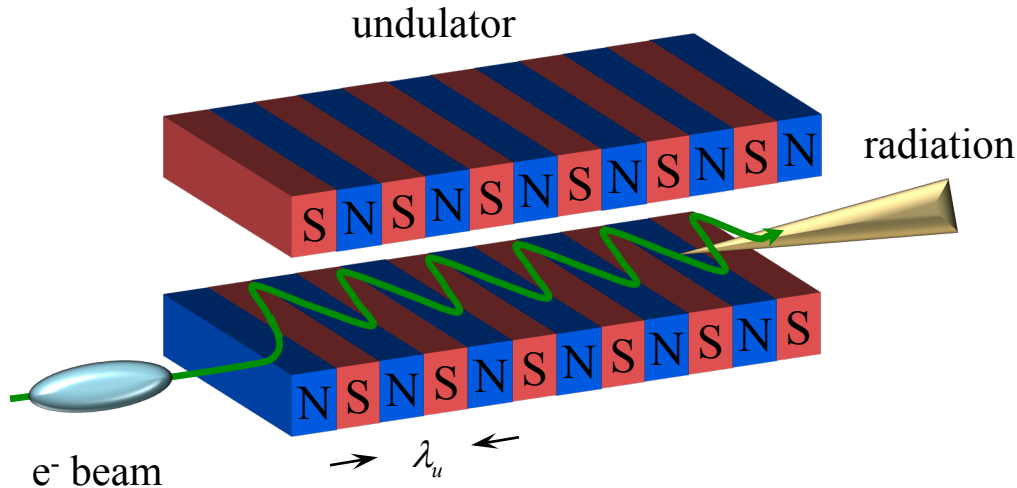
Los Alamos National Laboratory

2011 Particle Accelerator Conference, New York, NY

Abstract

One of the options for increasing the longitudinal coherency of the X-ray FELs is creating the electron beam bunching at the X-ray wavelength scale. Several schemes, such as HGHG, EEHG, transverse beam masking before the Emittance Exchanger (EEX), leading to significant amplitude of the beam microbunching were recently proposed. All these scheme rely on the beam optics which include several magnetic dipoles. While the beam passes through the dipole, its energy spread increases due to quantum nature of synchrotron radiation. As a result, the bunching factor at small wavelengths reduces since electrons having different energies follow different trajectories in the bend. We study general concept of the electron beam masking and determine the beam optics which transforms the induced beam modulation into the longitudinal bunching. We rigorously calculate the reduction in the bunching factor due to incoherent synchrotron radiation (ISR) while the beam travels through the beam optics. We demonstrate that the bunching smearing in chicanes is much larger than the bunching smearing in the EEX consisting of the same bends. We determine parameters of the EEX optics which result in the smallest decrease of the electron bunching due to ISR-induced energy diffusion.

FEL principles



Radiation slips ahead of the electron beam by one wavelength after one undulator wavelength travel distance

Coherency of SASE light

Full transverse coherence if $L > Z_R$ or $L > \beta_x$ to provide transverse mixing between light and electron beam

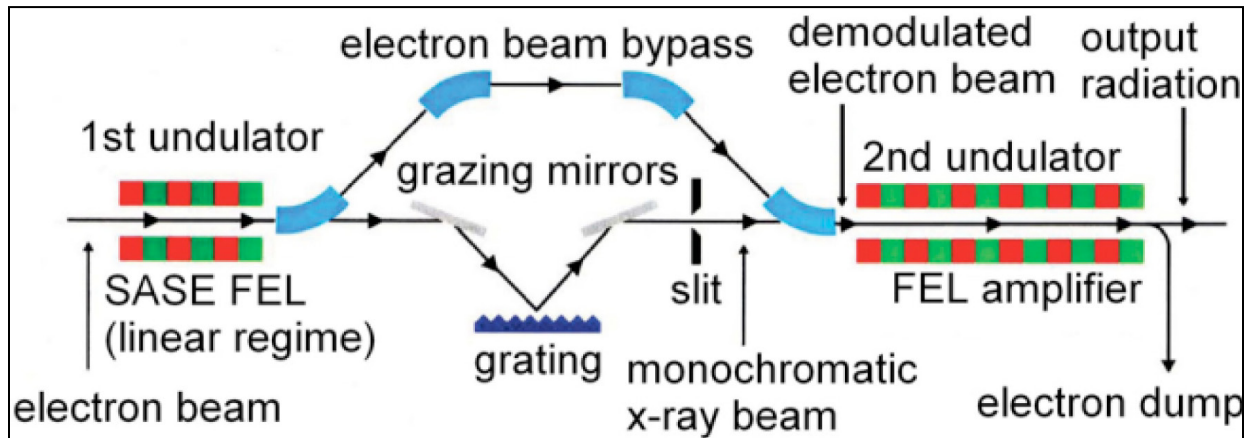
$\Delta\omega/\omega \sim \rho$ due to limited longitudinal mixing between light and electron beam

$$\lambda_{X-ray} = \frac{\lambda_u (1 + K^2/2)}{2\gamma^2}$$

Seeding schemes

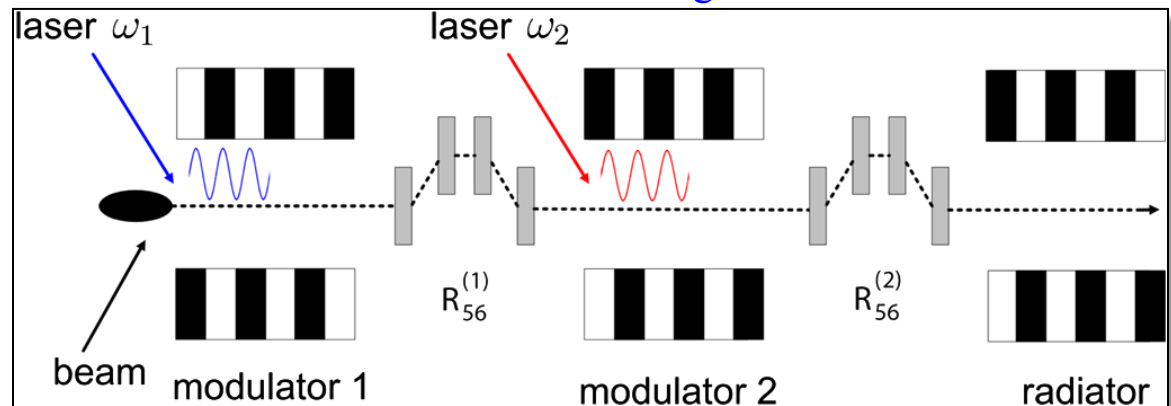
FEL mode couples electron bunching and radiation. Therefore, FEL can be seeded either by the coherent radiation or by beam bunching at the resonant wavelength.

optical seeding



J. Feldhaus et al.,
Opt. Comm. 140, 341 (1997).

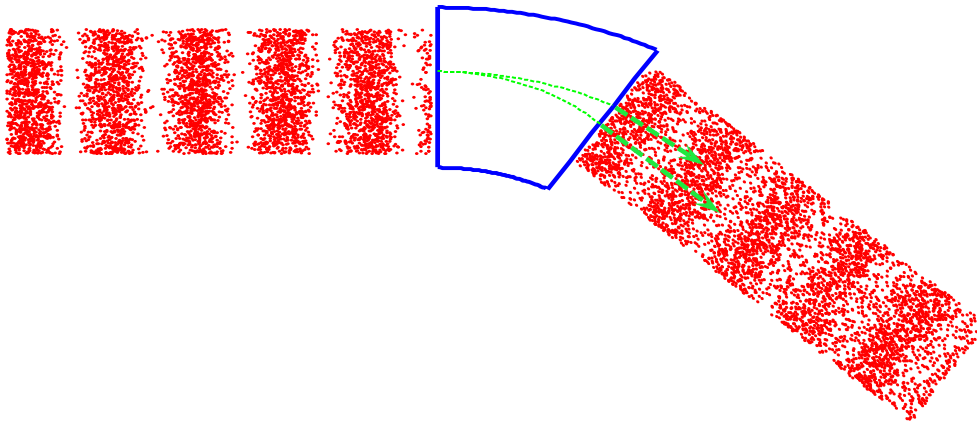
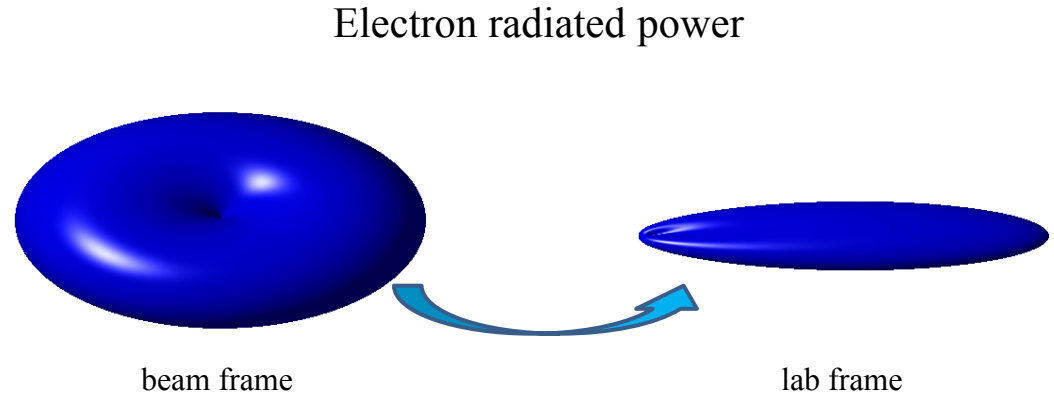
beam seeding



D. Xiang and G. Stupakov,
Phys. Rev. Lett. **12**, 030702 (2009).

Mechanism for bunching degradation

Electrons emit photons in quanta which frequency (and quanta energy) strongly depends on the angle of photon emission due to Doppler shift.

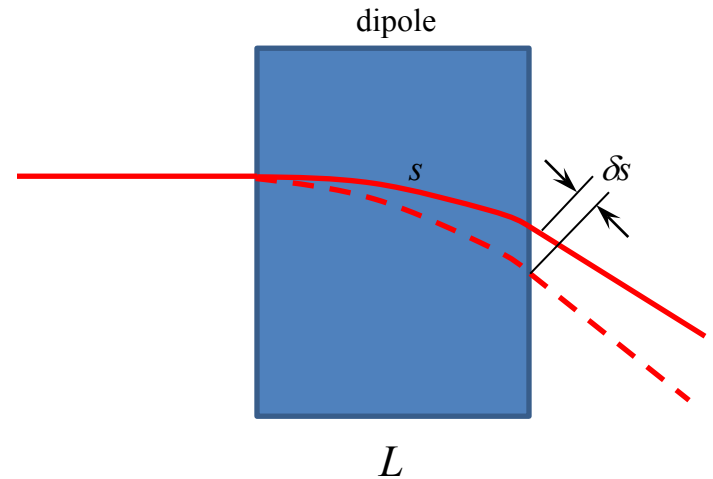


Two electrons with close 6D position in the phase space may end up at different positions after passing the bend. As a result, bunching degrades.

Qualitative estimate

Energy diffusion due to quantum nature of incoherent synchrotron radiation

$$\frac{\delta\gamma}{\gamma} = \sqrt{\frac{55}{48\sqrt{3}}} \sqrt{\frac{\hbar e^5 B^3}{4\pi\epsilon_0 m^5 c^6}} \gamma s^{1/2}$$



Electrons having different energies travel different distance in the bend

$$L = \rho \sin \alpha$$

$$s = \rho \alpha$$

$$\rho = \frac{\gamma mc}{eB}$$

$$s = \rho \arcsin \frac{L}{\rho} \cong L \left(1 + \frac{1}{6} \left(\frac{L}{\rho} \right)^2 \right)$$

$$\delta s = \frac{\partial s}{\partial \rho} \delta \rho = -\frac{1}{3} \alpha^2 \frac{\delta \gamma}{\gamma}$$

Electron bunching does not degrade if

$$\delta s < \lambda_{X-ray} \quad 3.37 \alpha^{7/2} [\text{deg}] \left(\frac{E}{10 \text{ GeV}} \right)^{5/2} < \lambda_{X-ray} \left[\overset{\circ}{\text{\AA}} \right]$$

Vlasov Equation

Vlasov equation in Beam Physics

$$\frac{d\vec{R}}{ds} = P(s)\vec{R}$$

Electron coordinates in 6D phase space change linearly under linear forces applied

differential transform matrix

formal solution

$$\vec{R}(s) \equiv \exp\left(\int_{s_0}^s P(s')ds'\right)\vec{R}(s_0) \Leftrightarrow \vec{R}(s) = M(s_0 \rightarrow s)\vec{R}(s_0)$$

conventional transform matrix

constructing Vlasov equation

$$\partial_t f + \vec{V} \cdot \nabla_{\vec{R}} f = 0 \quad \dot{\vec{R}} = \vec{V}$$

$$\partial_s f + \nabla_{\vec{R}} f \cdot P\vec{R} = 0$$

conventional Vlasov equation in Plasma Physics

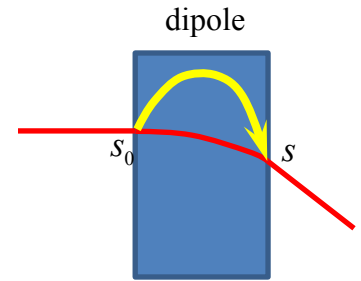
$$\partial_t f + \vec{v} \cdot \nabla f + \vec{F} \cdot \partial_{\vec{p}} f = 0$$

$$\frac{dt}{1} = \frac{dx_i}{v_i} = \frac{dp_i}{F_i} \Rightarrow \dot{\vec{x}} = \vec{v}, \quad \dot{\vec{p}} = \vec{F}$$

Newton equation

Example: bend

$$P_{Bend} = \begin{pmatrix} 0 & \rho & 0 & 0 & 0 & 0 \\ -1/\rho & 0 & 0 & 0 & 0 & 1 \\ 0 & 0 & 0 & \rho & 0 & 0 \\ 0 & 0 & 0 & 0 & 0 & 0 \\ 1 & 0 & 0 & 0 & 0 & 0 \\ 0 & 0 & 0 & 0 & 0 & 0 \end{pmatrix}$$



$$M_{Bend}(\alpha) = e^{\int P d\alpha} = \begin{pmatrix} \cos \alpha & \rho \sin \alpha & 0 & 0 & 0 & \rho(1 - \cos \alpha) \\ -\sin \alpha / \rho & \cos \alpha & 0 & 0 & 0 & \sin \alpha \\ 0 & 0 & 1 & \rho \alpha & 0 & 0 \\ 0 & 0 & 0 & 1 & 0 & 0 \\ -\sin \alpha & -\rho(1 - \cos \alpha) & 0 & 0 & 1 & -\rho(\alpha - \sin \alpha) \\ 0 & 0 & 0 & 0 & 0 & 1 \end{pmatrix}$$

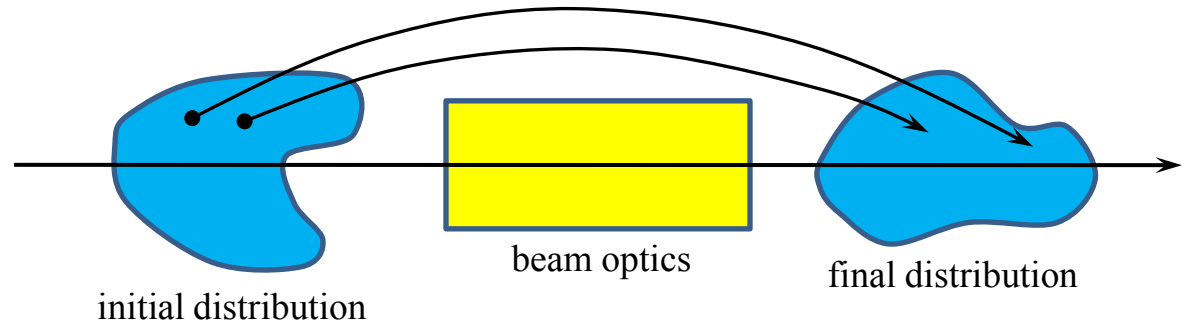
Transform of beam modulation

$$\partial_s f + \nabla_{\vec{R}} f \cdot P\vec{R} = 0$$

Vlasov equation can be formally solved by tracing back the position of each electron

$$f(\vec{R}, s) = f_0(M^{-1}(s_0 \rightarrow s)\vec{R}, s_0)$$

i.e. phase space density does not change along the trajectory (Liouville theorem)



$$f_0(\vec{R}) = \underbrace{\bar{f}_0(\vec{R})}_{\text{slowly changing beam envelope}} \underbrace{e^{i\vec{k}_0^T \vec{R}}}_{\text{monochromatic modulation}}$$

beam optics

$$f(\vec{R}, s) = \underbrace{\bar{f}_0(M^{-1}\vec{R})}_{\text{new envelope}} \underbrace{e^{i\vec{k}_0^T M^{-1}\vec{R}}}_{\text{new modulation}}$$

Transforms of electron coordinates and modulation wavevector

$$\vec{R} = M\vec{R}_0$$

$$\vec{k} = M^{-T}\vec{k}_0$$

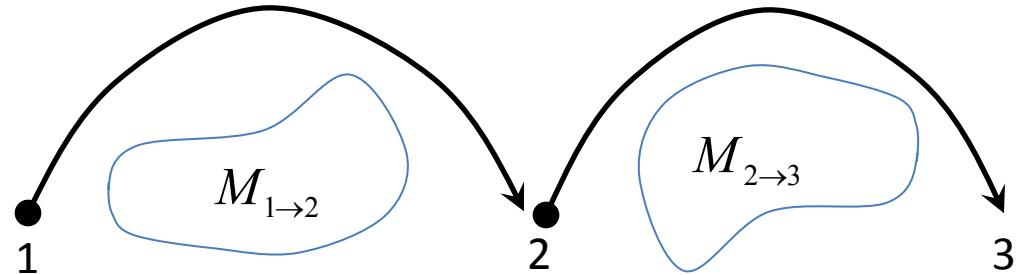
Speculative math

Transform matrix for the wavevector should depend on the beam transform matrix. It can include simple matrix operations like self matrix, inversion, and transposition

$$\vec{R} = M\vec{R}_0$$

$$\vec{k} = W\vec{k}_0$$

$$W(M) = M, M^{-1}, M^T, M^{-T}$$



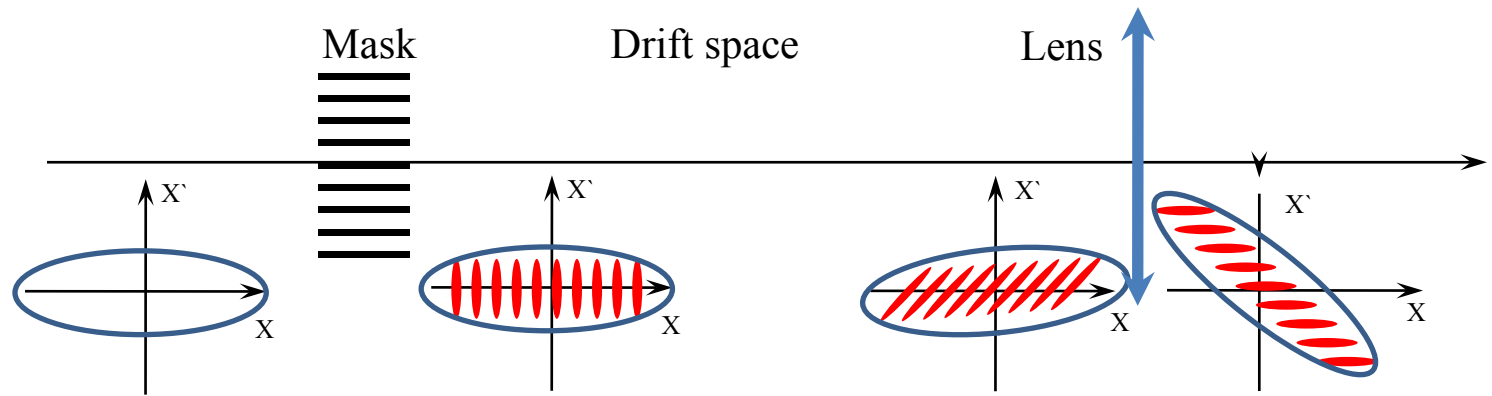
In a beamline consisting of two consecutive elements both the transform matrix for electron position and modulation wavenumber should be a product of individual transform matrices

$$M(1 \rightarrow 3) = M(2 \rightarrow 3)M(1 \rightarrow 2)$$

$$W(1 \rightarrow 3) = W(2 \rightarrow 3) W(1 \rightarrow 2)$$

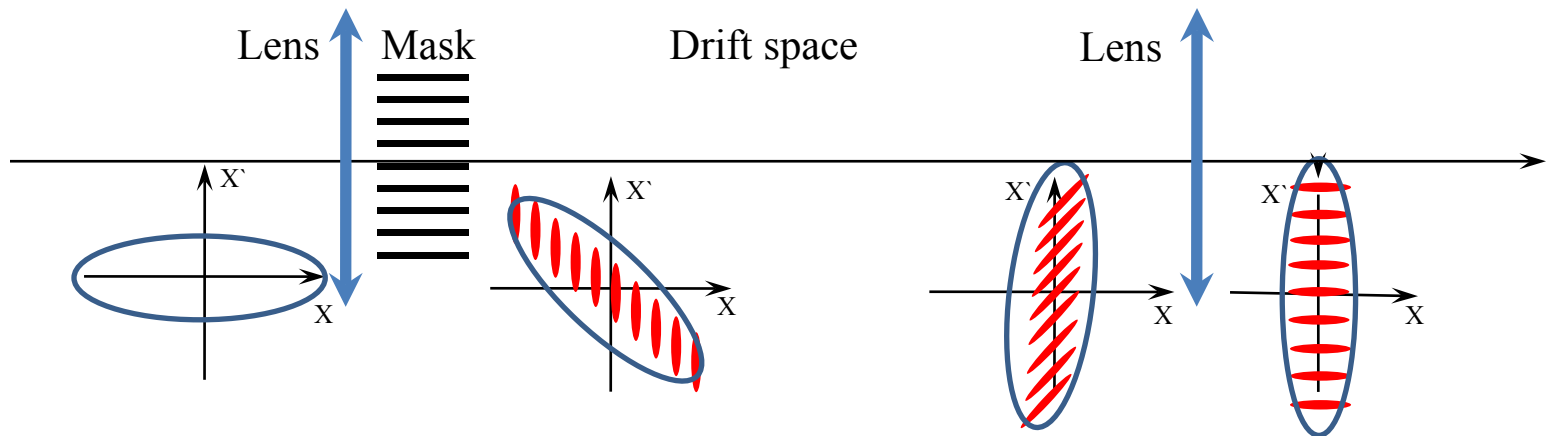
$$W(M_2 M_1) = W(M_2) W(M_1) \quad \Rightarrow \quad W = M \text{ or } W = M^{-T}$$

Illustration of modulation transform



scheme for creating x' modulation in the beam

Beam envelope and modulation wavevector transform differently. The beamline should be designed carefully to track evolution of both parameters simultaneously



scheme for creating x' modulation in the beam waist

Advantages of description

initial state

$$f_0(\vec{R}) = \frac{1}{(2\pi)^3} \exp\left(-\frac{1}{2} \vec{R}^T \Sigma_0^{-1} \vec{R}\right) \exp(i\vec{k}_0^T \vec{R})$$

beam envelope $\Sigma_0 = \langle \vec{R}^T \vec{R} \rangle_{f_0}$

modulation with \vec{k}_0

final state

$$f(\vec{R}) = \frac{1}{(2\pi)^3} \exp\left(-\frac{1}{2} \vec{R}^T \Sigma^{-1} \vec{R}\right) \exp(i\vec{k}^T \vec{R})$$

beam envelope $\Sigma = \langle \vec{R}^T \vec{R} \rangle_f$

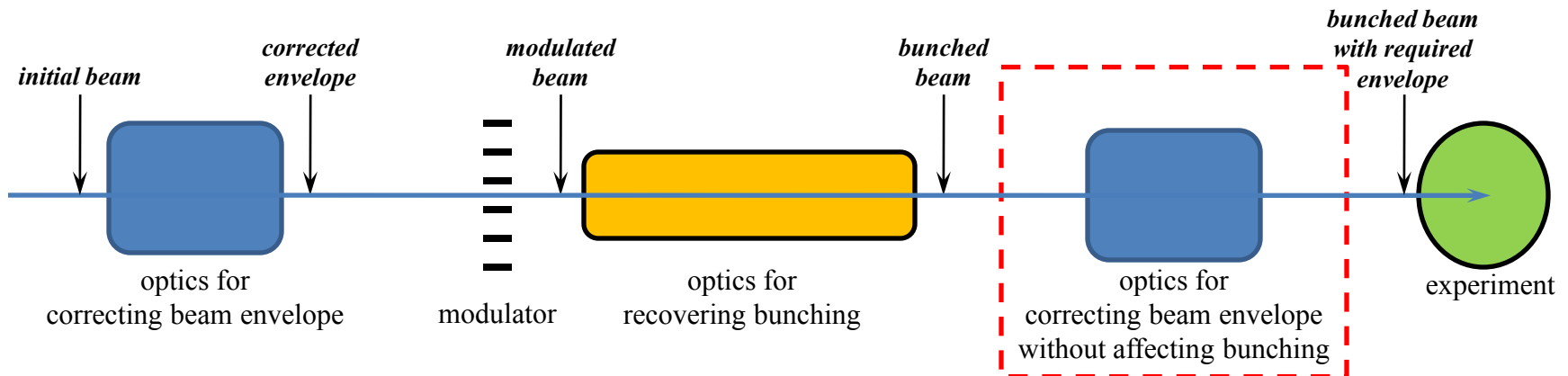
modulation with \vec{k}

Transform of beam parameters

$\Sigma = M \Sigma_0 M^T \qquad \vec{k} = M^{-T} \vec{k}_0$

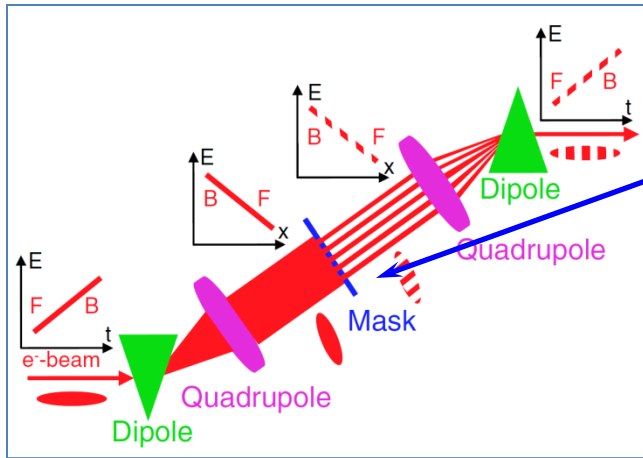
The problem generating a bunched beam with given envelope can be split into two problems:

1. One needs to determine the beamline which recovers required beam modulations
2. Placing additional beam transport upstream from the modulator section provides control over the resulting beam envelope

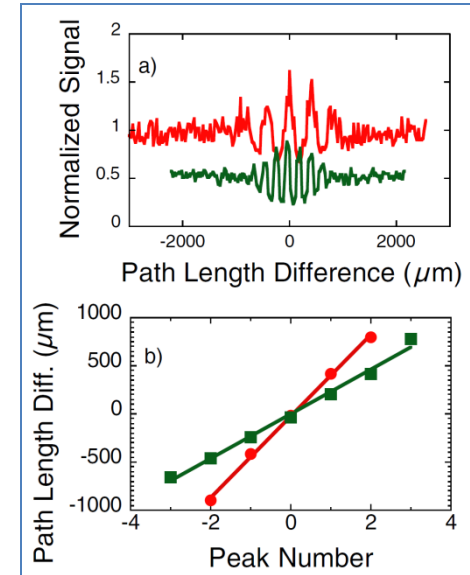


Examples of nonoptimal optics

Generation of trains of microbunches in Brookhaven Lab



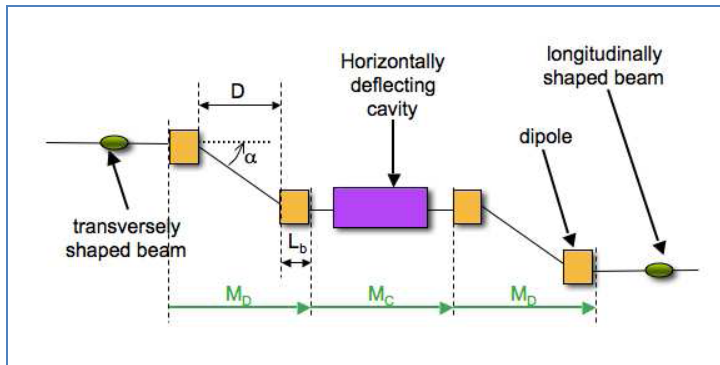
$$\sigma_\eta = \eta_x \left| \frac{\Delta\gamma}{\gamma} \right| \gg \sigma_x = \sqrt{\frac{\beta_x \varepsilon_{xn}}{\gamma}}$$



P. Muggli *et al.*, Phys. Rev. Lett **101**, 054801 (2008).

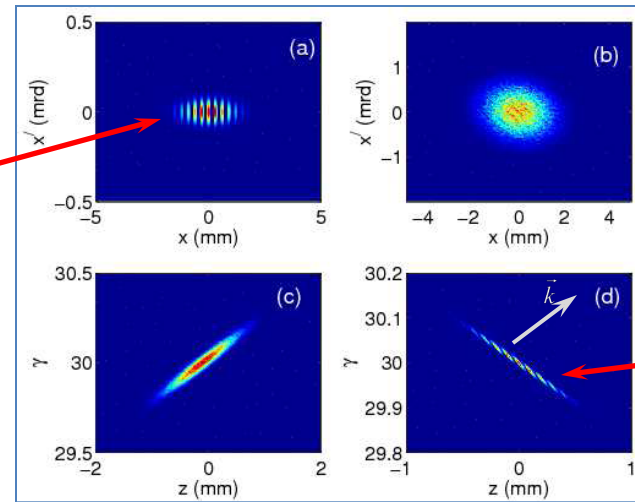
Both schemes work *ONLY* for transversally bright beams

Emittance Exchanger study at Fermilab



Y.-E. Sun *et al.*, arXiv 2010.

$$\lambda_x \geq \sqrt{\beta_z \varepsilon_x}$$



Imperfectly transformed beam modulations

Fokker-Planck Equation

Quantum nature of incoherent synchrotron radiation results
in the energy diffusion for electrons

$$\langle \Delta z'^2 \rangle^{1/2} = \sqrt{2Ds}$$

introduces
diffusion equation

$$\partial_s f = D \partial_{z'z'}^2 f$$

$$\partial_s f + \nabla_{\vec{R}} f \cdot P\vec{R} = D \partial_{z'z'}^2 f - v \partial_{z'} f$$

diffusion term
drag term

$$D = \frac{55}{96\sqrt{3}} \frac{\hbar e^5 B^3}{4\pi\epsilon_0 m_e^5 c^6} \gamma^2$$

Energy diffusion affects the envelope evolution much smaller than the evolution of modulation

initial distribution function

$$f_0(\vec{R}) = A e^{i\vec{k}_0^T \vec{R}}$$

Fokker-Planck equation
is linear, then evolution
of each harmonic is
independent from others

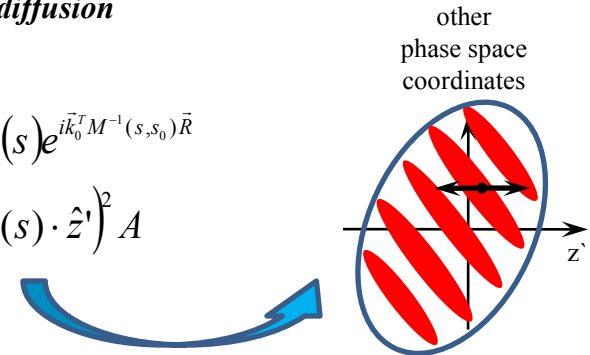
*distribution function
without energy diffusion*

$$f(\vec{R}, s) = A e^{i\vec{k}_0^T M^{-1}(s, s_0) \vec{R}}$$

*distribution function
with energy diffusion*

$$f(\vec{R}, s) = A(s) e^{i\vec{k}_0^T M^{-1}(s, s_0) \vec{R}}$$

$$\frac{dA}{ds} = -D \left(\vec{k}(s) \cdot \hat{z}' \right)^2 A$$



Symmetric beamline

Formal solution of Fokker-Planck equation

$$A(s) = A(s_0) \exp \left(- \int_{s_0}^{s_f} D k_z^2(s) ds \right) = A(s_0) \exp \left(- \int_{s_0}^{s_f} D (k_0^T M^{-1}(s_0 \rightarrow s) \hat{z})^2 ds \right)$$

Expressing solution through final modulation

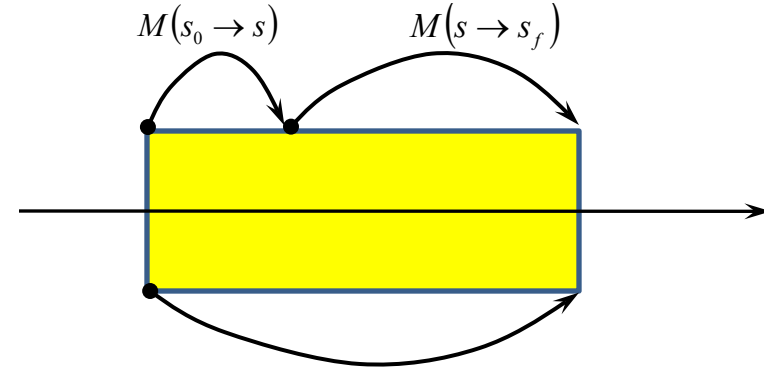
$$A(s) = A(s_0) \exp \left(- \int_{s_0}^{s_f} D (k_f^T M^{-1}(s \rightarrow s_f) \hat{z})^2 ds \right)$$

$$\vec{k}_f = M(s_0 \rightarrow s_f) \vec{k}_0$$

$$M(s_1 \rightarrow s_2) = \exp \left(\int_{s_1}^{s_2} P(s') ds' \right)$$

$$M^{-1}(s \rightarrow s_f) = M(s_f \rightarrow s)$$

$$A(s) = A(s_0) \exp \left(- \int_{s_0}^{s_f} D (k_f^T M(s_f \rightarrow s) \hat{z})^2 ds \right)$$



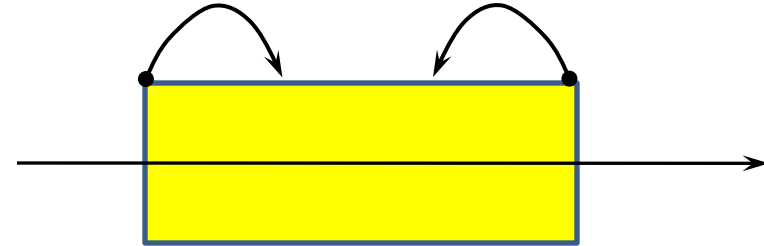
$$M(s_0 \rightarrow s_f) = M(s \rightarrow s_f) M(s_0 \rightarrow s)$$

Symmetric beamline, such as: dipole, chicane, EEX, etc.

$$A(s) = A(s_0) \exp \left(- \int_{s_0}^{s_f} D (k_f^T M(s_0 \rightarrow s) \hat{z})^2 ds \right)$$

$$\vec{k}_f^T = [0, 0, 0, 0, k_{X-ray}, 0]$$

$$M_{ij}^2(s_0 \rightarrow s_0 + \Delta s) = M_{ij}^2(s_f \rightarrow s_f - \Delta s)$$

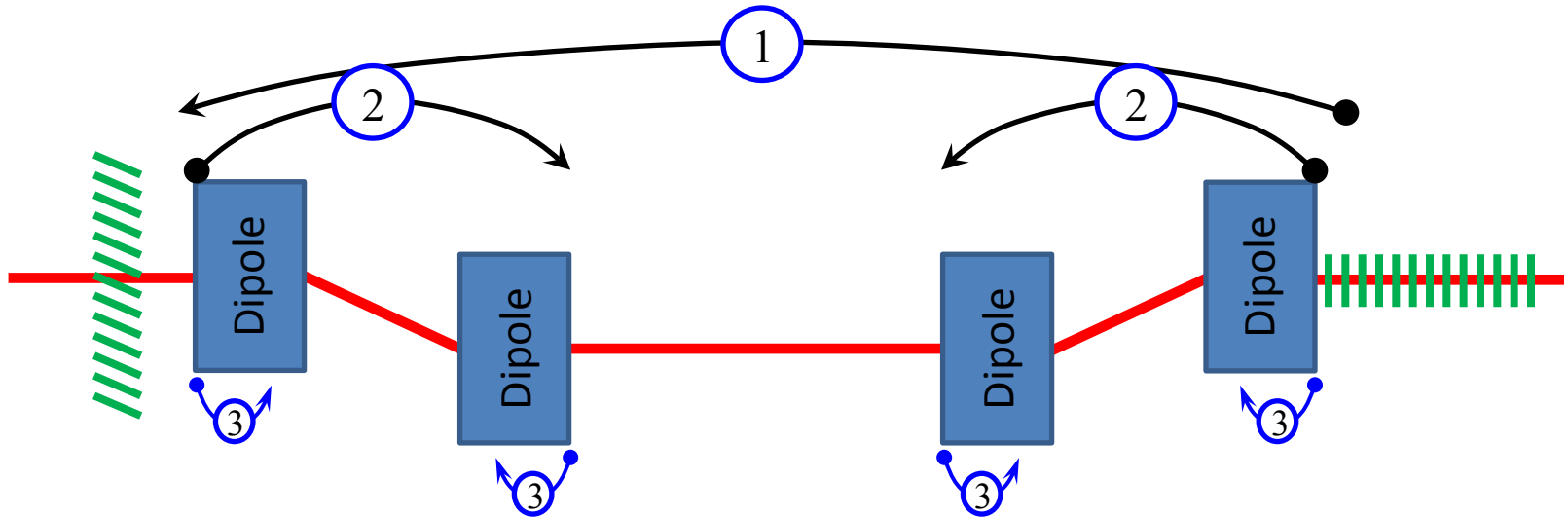


$$A(s) = A(s_0) \exp \left(- k_{X-ray}^2 \int_{s_0}^{s_f} D M_{56}^2(s) ds \right)$$

Calculating modulation smearing in beamline

Example: chicane

$$M_{chicane} = M_{flip} M_{dogleg} M_{flip} M_{drift} M_{dogleg} = \begin{bmatrix} 1 & S + 2L & 0 & 0 \\ 0 & 1 & 0 & 0 \\ 0 & 0 & 1 & 2\xi \\ 0 & 0 & 0 & 1 \end{bmatrix} \quad M_{dogleg} = \begin{bmatrix} 1 & L & 0 & \eta \\ 0 & 1 & 0 & 0 \\ 0 & \eta & 1 & \xi \\ 0 & 0 & 0 & 1 \end{bmatrix}$$



Algorithm for calculating bunching degradation

1. Calculate the required bunching wavenumber at the beginning of optics $k_0 = M^T k_f$;
2. Calculate the modulation wavenumber at each dipole entrance or exit;
3. Calculate the modulation wavenumber at each point inside the dipole knowing the modulation wavenumber at its edge;
4. Integrate attenuation of modulation knowing k_z inside the dipole, $dA/ds = -Dk_z^2 \cdot A$;
5. Repeat steps 3-4 for each dipole;

$$A = A_0 \exp \left[-2347 \left(\frac{E}{10 \text{ GeV}} \right)^5 \left(\frac{1 \text{ \AA}}{\lambda_{X\text{-ray}}} \right)^2 (\alpha [\text{deg}])^7 \left[\left(\frac{R_{56}}{\alpha^3 \rho} \right)^2 + 0.11 \right] \right]$$

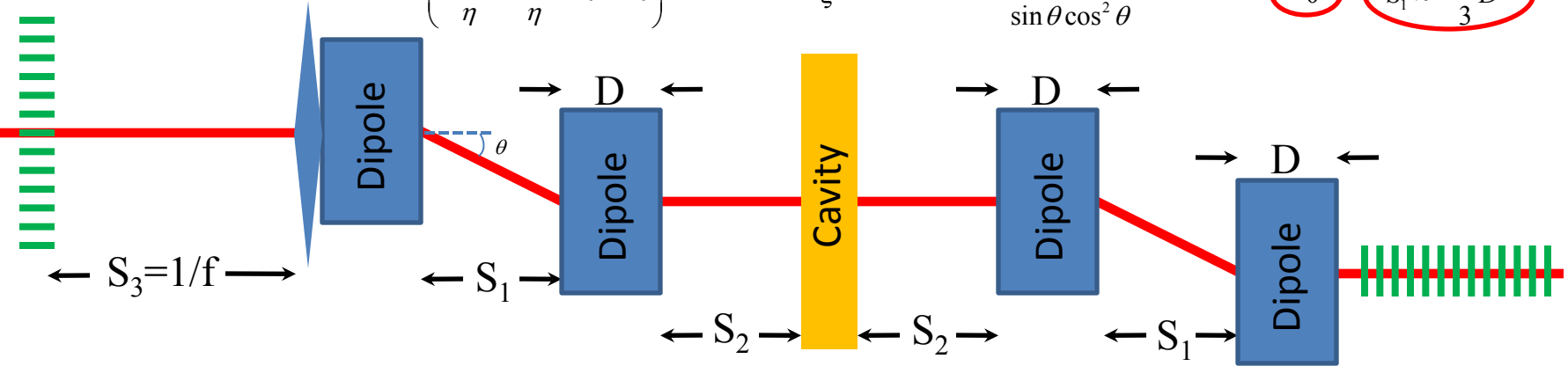
Electron bunching through Emittance Exchanger (EEX)

$$M_{EEX} = M_{dogleg} M_{drift} M_{cavity} M_{drift} M_{dogleg} = \begin{pmatrix} 0 & 0 & -\frac{L}{\eta} & \eta \\ 0 & 0 & -\frac{1}{\eta} & 0 \\ 0 & \eta & 0 & 0 \\ -\frac{1}{\eta} & -\frac{L}{\eta} & 0 & 0 \end{pmatrix}$$

$$L = \frac{2D \cos \theta + S_1}{\cos^2 \theta} + S_2$$

$$\eta = -\frac{1}{\kappa} = \frac{S_1 + 2D \cos \theta - (2D + S_1) \cos^2 \theta}{\sin \theta \cos^2 \theta}$$

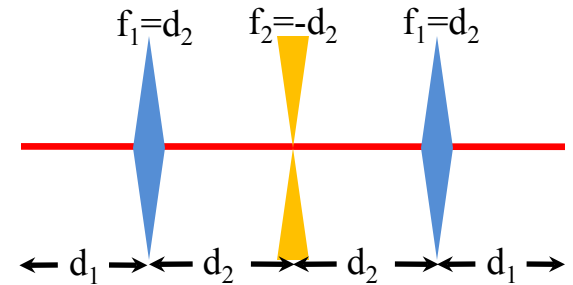
$$\xi = \frac{2D \sin \theta \cos \theta + S_1 \sin^3 \theta - 2D \theta \cos^2 \theta}{\sin \theta \cos^2 \theta} = 0 \quad S_1 \approx -\frac{2}{3} D$$



Initial wavenumber of modulation $\vec{k}_0 = M^T \vec{k}_f = [0, k_x, 0, 0]^T$
can be created from x-modulation by placing additional
drift+lens optics before the EEX

$$A = A_0 \exp \left[-195 \left(\frac{E}{10 \text{ GeV}} \right)^5 \left(\frac{1 \text{ A}}{\lambda_{X\text{-ray}}} \right)^2 (\alpha [\text{deg}])^7 \right]$$

Negative drift space



$$M_{\text{triplet}}(d_1, d_2) = \begin{bmatrix} -1 & -2d_1 + 3d_2 & 0 & 0 \\ 0 & -1 & 0 & 0 \\ 0 & 0 & 1 & \frac{4(d_1 + d_2)}{\gamma^2} \\ 0 & 0 & 0 & 1 \end{bmatrix}$$

Comparison of bunching smearing in different beamlines

Single bend

qualitative estimate

$$3.37\alpha^{7/2}[\text{deg}]\left(\frac{E}{10\text{GeV}}\right)^{5/2} < \lambda_{X\text{-ray}}\left[\frac{\circ}{\text{\AA}}\right]$$

quantitative estimate

$$\begin{aligned} A &= A_0 \exp\left(-\frac{55\pi^2}{63 \cdot 96\sqrt{3}}\alpha^7\gamma^5 \frac{1}{\alpha_{\text{fine}}}\left(\frac{r_e}{\lambda_{X\text{-ray}}}\right)^2\right) = \\ &= A_0 \exp\left(-8\left(\frac{1\text{\AA}}{\lambda_{X\text{-ray}}}\right)^2\left(\frac{E}{10\text{GeV}}\right)^5\alpha^7[\text{deg}]\right), \end{aligned}$$

Emittance EXchanger

$$A = A_0 \exp\left(-195\left(\frac{E}{10\text{GeV}}\right)^5\left(\frac{1\text{\AA}}{\lambda_{X\text{-ray}}}\right)^2(\alpha[\text{deg}])^7\right)$$

Chicane

$$A = A_0 \exp\left(-2347\left(\frac{E}{10\text{GeV}}\right)^5\left(\frac{1\text{\AA}}{\lambda_{X\text{-ray}}}\right)^2(\alpha[\text{deg}])^7\left[\left(\frac{R_{56}}{\alpha^3\rho}\right)^2 + 0.11\right]\right)$$

Echo-Enabled Harmonic Generation (EEHG)

$$A = A_0 \exp\left(-1.9 \cdot 10^{-3}\left(\frac{E}{10\text{GeV}}\right)^3 \frac{\alpha[\text{deg}]}{B^2[\text{T}]} \frac{N_{\text{harm}}^2}{(\Delta\gamma/\gamma[0.01\%])^2}\right)$$

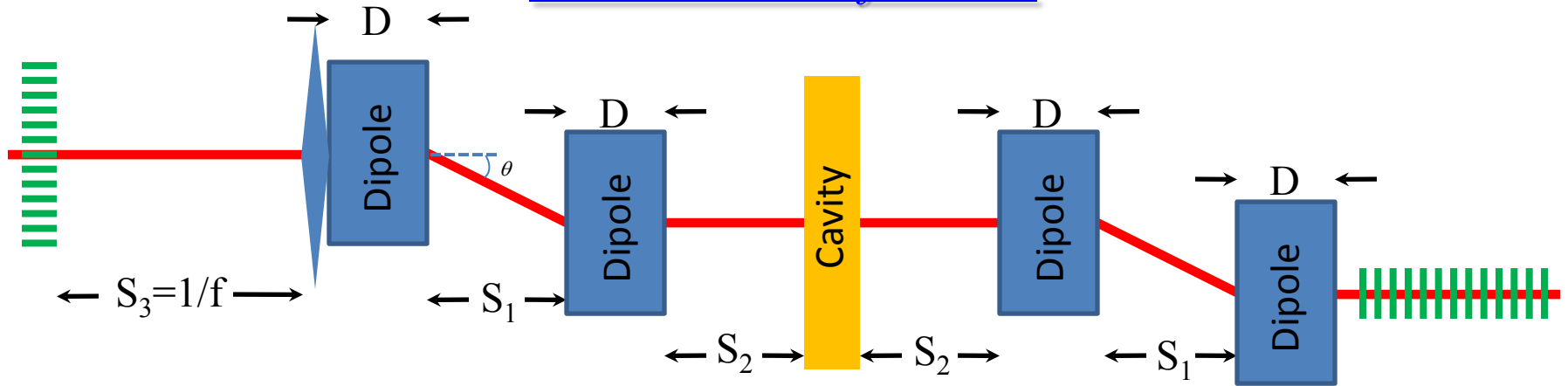
$$N_{\text{harm}}^{\text{LCLS}} = 13.6 \frac{B[\text{T}] \times \Delta\gamma/\gamma[0.01\%]}{\sqrt{\alpha[\text{deg}]}} \quad @14.2\text{GeV}$$

2 nm laser

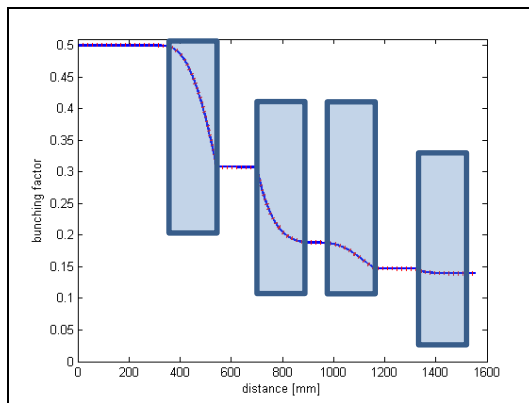
$$N_{\text{harm}}^{\text{LCLSII}} = 81.6 \frac{B[\text{T}] \times \Delta\gamma/\gamma[0.01\%]}{\sqrt{\alpha[\text{deg}]}} \quad @4.3\text{GeV}$$

500 nm laser

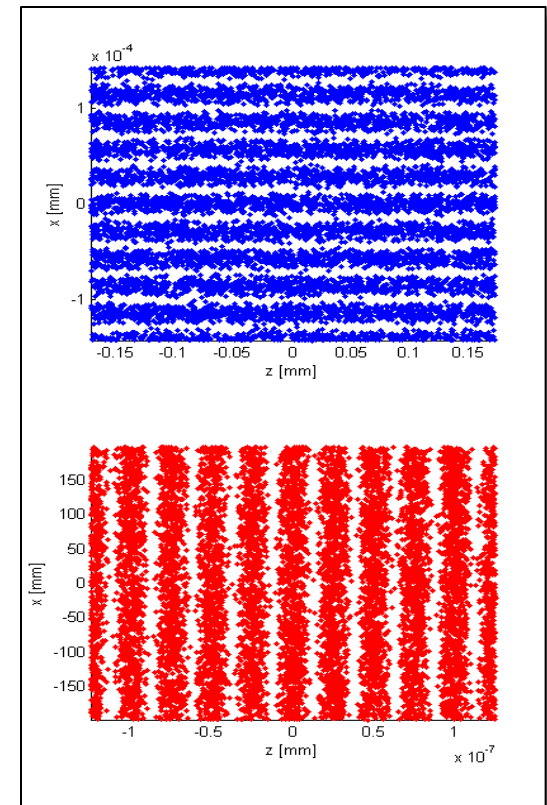
Numerical verification



1. Generate initial ensemble of electrons with transverse density modulation;
2. Push particles through beamline elements using linear beam matrix for each element;
3. Push particles inside each bend in several steps adding random energy change on each step;



$$B = 1 \text{ T}, \quad \alpha = 0.2^\circ, \quad E = 20 \text{ GeV}, \quad \lambda_{X\text{-ray}} = 0.25 \text{ \AA}$$



Consistency of continuous description

Central limit theorem

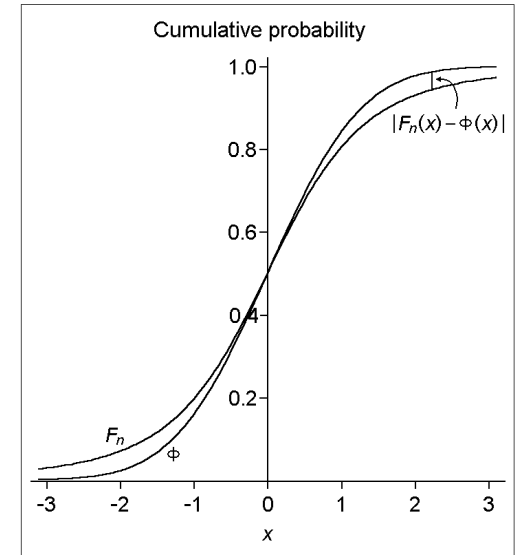
Each electron emits photons with about 100% distribution in photon energy. Central limit theorem states that if # of photon is large, electron energy approaches Gaussian statistics, i.e. electron dynamics can be described with diffusion equation.

Berry-Esseen theorem estimates how fast the distribution function approaches Gaussian

$$Y_n = \frac{X_1 + X_2 + \dots + X_n}{n}$$

$$F_n(x) = \int_{-\infty}^x Y_n(x) dx$$

$$|F_n(x) - \Phi(x)| < \frac{0.4785 \langle X^3 \rangle}{\langle X^2 \rangle^{3/2} \sqrt{n}} \sim \frac{1}{\sqrt{n}}$$



Bend angle radiation

Each electron emits α_{fine} photons per $1/\gamma$ bend angle

Total number of emitted photons by all electrons within one bunching wavelength

$$N_{h\omega} \sim \alpha_{fine} \frac{\alpha}{1/\gamma} \frac{I \lambda_{X-ray}}{ec} \sim 5.2 \cdot 10^3 \alpha[\text{deg}] \frac{E}{10 \text{ GeV}} \frac{\lambda_{X-ray}}{1 \text{ \AA}} I[\text{kA}] \gg 1$$

Results

- Formalism describing the evolution of the monochromatic beam modulations in the beamline is developed.
- Rigorous formalism describing smearing of the beam modulations due ISR-induced energy spread is developed. Straightforward algorithm for calculating the smearing effect in an arbitrary beamline is described.
- It is demonstrated that the beam bunching degradation is caused by the beamline dispersion in case of symmetric beamline.
- Smearing out of beam modulation in chicane and EEX is calculated. It is demonstrated that bunching degradation in chicane is much stronger than in EEX since chicane has nonzero dispersion.
- Analytical results are verified numerically.